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"RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 2814" RECEIVED

RESPONSE UNDER 37 C.F.R. §1.116 -
EXPEDITED PROCEDURE EXAMINING GROUP 2814

JUN 23 2003
TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
TOSHIAKI SHINOHARA : EXAMINER: NGUYEN, DILINH P.
SERIAL NO: 09/895,319 :
FILED: JULY 2, 2001 : GROUP ART UNIT: 2814
FOR: SEMICONDUCTOR DEVICE AND :
METHOD OF MANUFACTURING :
SAME :

REQUEST FOR RECONSIDERATION

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

This communication is in response to the Office Action dated March 24, 2003.

REMARKS

Favorable reconsideration of this application in light of the following discussion is respectfully requested.

Claims 1-8 are pending in the present application. The pending claims are maintained by the present response.

In the outstanding Office Action, Claims 1-6 were rejected under 35 U.S.C. § 103(a) as unpatentable over Noda et al. (U.S. Patent 5,767,573, herein "Noda") in view of Ueno et al. (U.S. Patent 6,297,959, herein "Ueno"); Claim 7 was rejected under 35 U.S.C. § 103(a) as